



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date December 12, 2005

In re the Application of

Takeo KAGAMI et al.

Group Art Unit: 2653

Application No.: 10/600,444

Examiner: A. HEINZ

Filed: June 23, 2003

Docket No.: 116329

For: MAGNETO-RESISTIVE DEVICE WITH REDUCED SUSCEPTIBILITY TO ION BEAM  
DAMAGE (AS AMENDED)

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 11, 2005, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 173978 in the amount of \$120 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
 Extension fee for response within second month pursuant to §1.136(a) (\$450.00)  
 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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12/13/2005 JADD01 00000029 10600444  
JAO:KLK Etch:1251 120.00 OP  
03 FC:1201 600.00 OP  
04 FC:1202 360.00 OP

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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461